



Docket No.: 1514.1032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Serial No. 10/690,507

Group Art Unit: 1722

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Song, Matthew J.

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

August 11, 2006

Sir:

This is in response to the Office Action mailed April 18, 2006, and having a period for response set to expire on July 18, 2006.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.

08/14/2006 HAL111 00000015 10690507
01 FC:1251 120.00 OP